

**Amendments to the Claims:**

This listing of claims will replace all prior versions, and listings, of claims in the application:

**Listing of Claims:**

1. (Currently Amended) A piezoelectric/electrostrictive film type device comprising:

a ceramic substrate; formed of a ceramic, and

a piezoelectric/electrostrictive operation portion stacked on said substrate, said operation portion comprising in which at least one piezoelectric/electrostrictive layer having an upper exposed surface containing open pores and at least one pair of electrodes electrically connected to the said piezoelectric/electrostrictive layer, are stacked on the substrate,

wherein a highly water repellent surface is formed on a chemical structure of at least one of an outer surface of the said piezoelectric/electrostrictive layer and an upper electrode of said at least one pair of electrodes defines a highly water repellent surface.

2. (Currently Amended) ~~A~~ The piezoelectric/electrostrictive film type device according to claim 1,

~~—wherein said highly water repellent surface inhibits is modified in such an extent that infiltration of moisture infiltration into micro pores opened said open pores in at least one of of the said outer upper exposed surface of the said piezoelectric/electrostrictive layer and the upper electrode of said at least one pair of electrodes, and/or into a gap between the substrate and the piezoelectric/electrostrictive layer is sufficiently inhibited.~~

3. (New) The piezoelectric/electrostrictive film type device of claim 1, wherein said highly water repellent surface inhibits moisture infiltration into a gap between said ceramic substrate and said piezoelectric/electrostrictive layer.

4. (New) The piezoelectric/electrostrictive film type device of claim 1, wherein said highly water repellent surface includes fluorine.